FORM PTO/SB/08A/B (10-01) Substitute for PTO-1449A/B	Attorney Docket Number	57090/C982
INFORMATION DISCLOSURE **STATEMENT BY APPLICANT** (use as many sheets as necessary)	Application Number	10/556,858
	Filing Date	January 31, 2006
	Applicant(s)	Tiow Seng Tan, et al.
	Group Art Unit	2628
	Examiner Name	Merouan

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	Examiner Name	To be determined

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